

	L #	Hits	Search Text
1	L1	1	("5838426").PN.
2	L2	1	1 and ((chang\$3 or increas\$4 or decreas\$3) with (aperture or pattern or mask or reticle))
3	L3	162299	(mask or reticle) and (substrate or wafer)
4	L4	10238	((projection near optical) or lens) same (environment or atmosphere)
5	L5	38270	(measur\$5 or determin\$6 or sens\$3 or detect\$4) near3 (environment or atmosphere)
6	L6	459	4 same 5
7	L7	31262	(chang\$3 or adjust\$4 or modif\$5 or correct\$4) near4 wavelength
8	L8	48	6 and 7
9	L9	32	@ad<="20010529" and 8

PK

1/21/05